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Paper Number 14

In re application of :
Hiroaki Okamoto et al. :
Serial No. 09/601,474 :
Filed: October 17, 2000 :
For: METHOD OF FORMING PROTECTIVE COATING ON CELL :
SAFETY VALVE ELEMENT, CELL SAFETY VALVE :
ELEMENT COATED WITH PROTECTIVE FILM, CELL :
SEALING PLATE USING THE ELEMENT, AND :
ENCLOSED CELL USING THE PLATE :

DECISION ON
PETITION

This is a response to the PETITION TO VACATE HOLDING OF ABANDONMENT, filed September 26, 2003. The petition asks that the abandonment, as set forth in the Notice of Abandonment of August 25, 2003, be withdrawn since the applicant did timely file a response on June 12, 2003.

DECISION

The instant request has been accepted as a petition to withdraw the holding of abandonment under the provisions of 37 CFR 1.181 (no fee) - no abandonment-in-fact. A review of the USPTO application file reveals that applicant's response, the REQUEST FOR CONTINUED EXAMINATION (RCE) and INFORMATION DISCLOSURE STATEMENT, were properly filed on June 12, 2003 in view of the fact that the originally filed papers having a Patent and Trademark Office date stamp of June 12, 2003 thereon have been located in the USPTO application file. Accordingly, any holding of abandonment is hereby vacated, and the application has been returned to pending status.

The application shall be forwarded to the examiner for processing and consideration of the papers filed June 12, 2003.

The Petition is **GRANTED**.

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